

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tohru Koike et al.
Appl. No. : 10/575,714
Filed : May 8, 2006
For : METHOD FOR MEASURING A SURFACE PLASMON
RESONANCE AND NOBLE METAL COMPOUND USED FOR THE
SAME

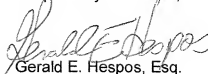
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CORRECTED INFORMATION DISCLOSURE STATEMENT

Sir:

The undersigned attorney for the applicants has realized that the Form PTO/SB/08A that accompanied the June 22, 2010 Information Disclosure Statement included a typographical mistake in the second of the two foreign document numbers listed on the Form PTO/SB/08A. The correct foreign number was presented on the Japanese Office Action that accompanied the Information Disclosure Statement and the correct document was attached to the Information Disclosure Statement. This corrected Information Disclosure Statement merely provides a replacement Form PTO/SB/08A to identify both of the newly cited references with their respective correct numbers. Please enter the correct Japanese reference numbers into the Official record of the United States Patent and Trademark Office.

Respectfully submitted,



Gerald E. Hespos, Esq.
Atty. Reg. No. 30,066
Customer No. 01218
HESPOS & PORCO LLP
110 West 40th Street - Suite 2501
New York, NY 10018
Tel. (212) 725-2450
Fax (212) 725-2452

Date: June 23, 2010